INTERNATIONAL GEMOLOGICAL INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

October 8, 2026

IGI Report Number	LG844680030
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	MARQUISE BRILLIANT
Measurements	14.75 X 7.68 X 4.69 MM

GRADING RESULTS

Carat Weight	3.06 CARATS
Color Grade	E
Clarity Grade	VS 1

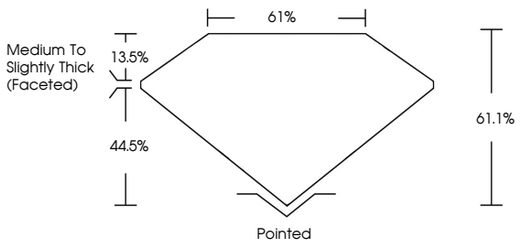
ADDITIONAL GRADING INFORMATION

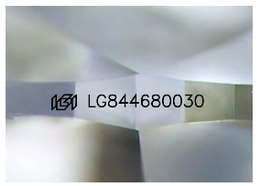
Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	IGI LG844680030

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG844680030
Report verification at igi.org

PROPORTIONS





Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

© IGI 2020, International Gemological Institute

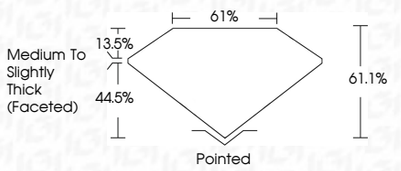
FD - 10 20

THIS DOCUMENT WAS PRODUCED WITH THE FOLLOWING SECURITY MEASURES: SPECIAL DOCUMENT PAPER, INK SCREENS, WATERMARK BACKGROUND DESIGNS, HOLOGRAM AND OTHER SECURITY FEATURES NOT LISTED AND DO EXCEED DOCUMENT SECURITY INDUSTRY GUIDELINES.

www.igi.org

LABORATORY GROWN DIAMOND REPORT

October 8, 2026
IGI Report Number LG844680030
Description LABORATORY GROWN DIAMOND
Shape and Cutting Style MARQUISE BRILLIANT
Measurements 14.75 X 7.68 X 4.69 MM
GRADING RESULTS
Carat Weight 3.06 CARATS
Color Grade E
Clarity Grade VS 1



ADDITIONAL GRADING INFORMATION
Polish EXCELLENT
Symmetry EXCELLENT
Fluorescence NONE
Inscription(s) IGI LG844680030
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

IGI

October 8, 2026
IGI Report No LG844680030
MARQUISE BRILLIANT
14.75 X 7.68 X 4.69 MM
Carat Weight 3.06 CARATS
Color Grade E
Clarity Grade VS 1
Depth 61.1%
Table 61%
Girdle Medium To Slightly Thick (Faceted)
Culet Pointed
Polish EXCELLENT
Symmetry EXCELLENT
Fluorescence NONE
Inscription(s) IGI LG844680030
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa